



Docket No. 0524-0139.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Nozawa et al.)
Serial No.: 10/771,997)
Filed: February 4, 2004)
For: Manufacturing Method And Apparatus of)
Phase Mask Shift Blank)
Examiner: Steven Versteeg)
Art Unit: 1753)

Do not enter SHV JH 18/2005

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 7/7/05

Signature

Date

AMENDMENT C (AFTER FINAL)

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Rejection of March 9, 2005, a one month extension of time being submitted herewith, please enter the following amendment in the above-identified application: